

**Notice of References Cited**

Application/Control No.

09/645,903

Applicant(s)/Patent Under  
Reexamination  
LI, LI

Examiner

Matthew W. Such

Art Unit

2891

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,417,385	11-1983	Temple, Victor A. K.	438/138
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Burkman, D.C., et al "Aqueous Cleaning Processes." Chapter 3. HANDBOOK OF SEMICONDUCTOR WAFER CLEANING TECHNOLOGY. Ed. Werner Kern. Werner Kern Associates: East Windsor, New Jersey. (1983): pp. 109-151.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.